



Attorney's Docket No.: 12732-002001 / US5117/5216/5217

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki
Serial No. : 09/917,677
Filed : July 31, 2001
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD
THEREFOR

Art Unit : 2879
Examiner : Unknown

Commissioner for Patents
Washington, D.C. 20231

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SEP 17 2001
TC 2800 MAIL ROOM

INFORMATION DISCLOSURE STATEMENT

Applicant submits the reference listed on the attached form PTO-1449, a copy of which is enclosed.

This statement is being filed within three months of the filing date of the application and before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: September 11, 2001

Signature of John F. Hayden

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Substitute Form PTO-1449
(Modified)U.S. Department of Commerce
Patent and Trademark OfficeAttorney's Docket No.
12732-062001Application No.
09/917,677**Information Disclosure Statement
by Applicant**

(Use several sheets if necessary)

(37 CFR 1.98(b))

Applicant
Shunpei YamazakiFiling Date
July 31, 2001Group Art Unit
2879**U.S. Patent Documents**

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	C.C. Wu et al; "Integration of Organic LED's and Amorphous Si TFT's onto Unbreakable Metal Foil Substrates"; 1996 International Electron Devices Meeting - Technical Digest; pp. 957-959; December 8-11, 1996
	AR	
	AS	
	AT	

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.